



Docket No. 740756-2045

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)
Kenji ITOH et al.) Group Art Unit: 1762
Serial No. 09/412,510) Examiner: M. Padgett
Filed: October 5, 1999)
For: PROCESS FOR TREATING A) Date: February 22, 2002
SUBSTRATE WITH A PLASMA)

#25/22
M. Padgett
3/23/02
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I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231, on February 22, 2002.

Deborah Tsepai
Deborah Tsepai

AMENDMENT

Commissioner for Patents
Washington, D.C. 20231

Sir:

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In response to the Office Action dated October 22, 2001 and further to a December 31, 2001 Information Disclosure Statement, please amend the above-identified application as follows"

IN THE CLAIMS:

Please cancel claims 40 and 41 without prejudice or disclaimer to the subject matter recited therein.

Please amend claims 20, 23, 25, 28, 31 and 32 as follows. Please note that the amended claims are presented below in their amended form. Furthermore, the claims are presented as attachment to the Amendment whereby the amendments are shown using the conventional technique of bracketing and underlining.

20. (Twice Amended) A process comprising the steps of: